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** CONTINUING DATA *****

This application is a CIP of 10/330,843 12/24/2002
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KW KCS

** FOREIGN APPLICATIONS *****

HW Nore

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** 09/22/2003

Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR COUNTRY CA	SHEETS DRAWING 10	TOTAL CLAIMS 39	INDEPENDENT CLAIMS 3
35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance	Verified and Acknowledged <i>[Signature]</i> Examiner's Signature	Initials		

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TITLE

Apparatus and method for depositing and planarizing thin films of semiconductor wafers

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